



ZfK

Patent  
Attorney's Docket No. 1018765-000143

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                                 |   |                            |
|---------------------------------|---|----------------------------|
| In re Patent Application of     | ) | <b>MAIL STOP ISSUE FEE</b> |
| Akio Kikkawa et al.             | ) | Group Art Unit: 1754       |
| Application No.: 10/633,552     | ) | Examiner: Wayne A Langel   |
| Filed: August 5, 2003           | ) | Confirmation No.: 6666     |
| For: PROCESSING METHOD FOR HIGH | ) |                            |
| PRESSURE GAS CONTAINER AND      | ) |                            |
| HALOGEN CONTAINING GAS          | ) |                            |
| FILLED IN SAID CONTAINER        | ) |                            |

**SUBMISSION OF INFORMATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of MPEP §609.04(b), please place in the file of the above-identified patent application the attached copy of U.S. Patent No. 5,803,795. The Korean counterpart patent of the '795 patent (KR 1997-5530) was cited by the Korean Examiner in the corresponding Korean patent application.

Should there be a need to discuss any aspect of the present application, the undersigned attorney may be contacted at the number provided below.

Respectfully submitted,

BUCHANAN INGERSOLL PC

Date: February 6, 2006

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